

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention	SEMICONDUCTOR DEVICE AND FABRICATION PROCESS THEREFOR
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Application Number :

Confirmation Number:

First Named Applicant: Lloyd Burrell

Attorney Docket Number: FIS920030011US1

Art Unit:

Examiner:

Search string: (5391516 or 6350667 or 5523626 or 20020068385 or 20010051426).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
P.M	1	5391516	1995-02-21	WOJNAROWSKI, ET AL.			
A.M	2	6350667	2002-02-26	CHEN, ET AL.			
A.M	3	5523626	1996-06-04	HAYASHI, ET AL.			

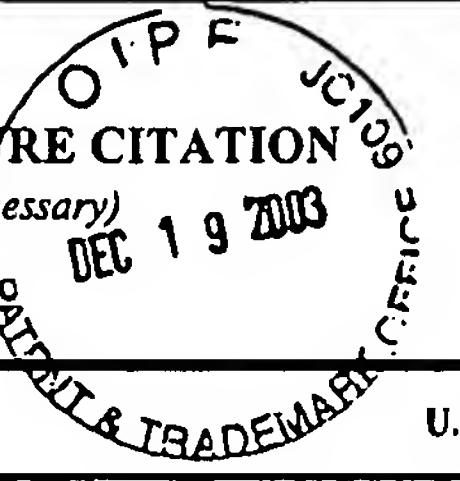
US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
A.M	1	20020068385	2002-06-06	MA, ET AL.			
A.M	2	20010051426	2001-12-13	POZDER, ET AL.			

Signature

Examiner Name	Date
ANH D. Mai	10/05/04

INFORMATION DISCLOSURE CITATION <small>(Use several sheets if necessary)</small>				Docket Number (Optional) FIS920030011US1		Application Number 10/605,369	
				Applicant(s) LLOYD BURELL, ET AL.			
				Filing Date 10/25/03	Group Art Unit 		
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
A.M		6,242,078	6/05/01	Pommer et al.	428	290	
A.M		6,435,398	8/20/02	Hartfield et al.	228	103	
FOREIGN PATENT DOCUMENTS							
REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
A.M	JP0008821A2		JAPAN			YES	NO
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
EXAMINER <i>ANH D. Mai</i>				DATE CONSIDERED <i>10/05/04</i>			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							